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Patent

JUN 22 2005

Customer No. 31561  
Docket No. 9788-US-PA  
Application No.: 10/065,874

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Applicant : Chia-Tien Peng  
Application No. : 10/065,874  
Filed : 2002/11/27  
For : METHOD FOR FABRICATING POLYSILICON LAYER  
Examiner : Fuller, Eric B  
Art Unit : 1762

**INFORMATION DISCLOSURE STATEMENT**  
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Enclosed are a PTO Form 1449 listing 1 reference of the above-identified application, a copy of the aforesaid reference, and its English translation. Pursuant to 37 CFR §1.56, Applicant is submitting the reference in compliance with his duty of disclosure. The Examiner is requested to make this reference a citation of official record.

No fee is believed to be due for this submission. However, the Commissioner is authorized to charge any fees required in connection with the submission of the IDS reference to Account No. 50-2620 (Order No.: 9788-US-PA)

The submission of the reference should not be interpreted as admitting it as prior art.

Respectfully Submitted,  
JIANG CHYUN Intellectual Property Office

Date: June 22, 2005

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